



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 7, 2026

IGI Report Number

LG826616178

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

SQUARE EMERALD CUT

Measurements

8.77 X 8.59 X 5.99 MM

GRADING RESULTS

Carat Weight

4.06 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG826616178

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LABORATORY GROWN DIAMOND REPORT



August 7, 2026

IGI Report Number

LG826616178

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

SQUARE EMERALD CUT

Measurements

8.77 X 8.59 X 5.99 MM

GRADING RESULTS

Carat Weight

4.06 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

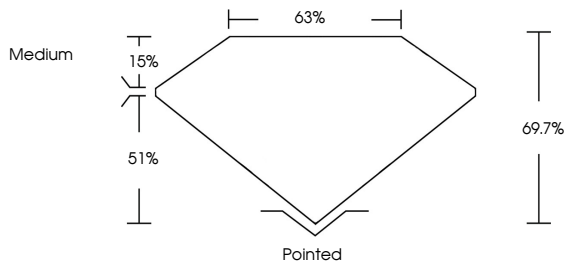
NONE

Inscription(s)

 LG826616178

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

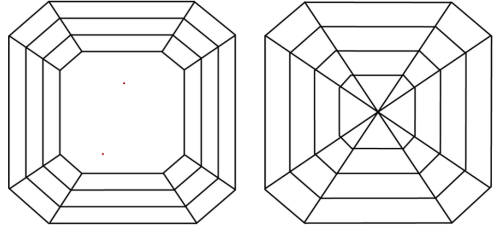
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



© IGI 2020, International Gemological Institute

FD - 10 20



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 7, 2026

IGI Report No LG826616178

SQUARE EMERALD CUT

8.77 X 8.59 X 5.99 MM

Carat Weight

4.06 CARATS

Color Grade

E

Clarity Grade

VVS 2

Depth

69.7%

Table

63%

Girdle

Medium

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG826616178

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa